

#10/Election
8/20/03
C Moore



03500.014241

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
	:	Examiner: J. Williams
NOBUHIRO ITO)	
	:	Group Art Unit: 2879
Application No.: 09/505,627)	
	:	
Filed: February 16, 2000)	
	:	
For: MANUFACTURING METHOD OF)	
ELECTRON BEAM APPARATUS	:	
AND SPACER, AND ELECTRON)	
BEAM APPARATUS	:	August 6, 2003

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Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO RESTRICTION REQUIREMENT

Sir:

This is in response to the Office Action dated July 29, 2003, imposing a restriction requirement in the above-identified application.

REMARKS

The Examiner has required election of a single disclosed invention for prosecution on the merits in this case. The Examiner alleged the existence of two patentably distinct inventions:

Group I: Claims 1-50, drawn to a method, drawn to a method of making an electron apparatus, classified in class 427, subclass 58; and

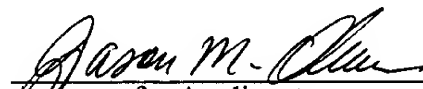
Group II: Claims 51-56, drawn to an electron apparatus, classified in class 313, subclass 495.

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Applicant hereby provisionally elects Group I, claims 1-50, with traverse.

Applicant's undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Attorney for Applicant

Registration No. 48,512

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3801
Facsimile: (212) 218-2200

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